

**Search Notes**

Application No.

10/028,712

Examiner

Wesley D Markham

Applicant(s)

FURUSAWA ET AL.

Art Unit

1762

**SEARCHED**

Class	Subclass	Date	Examiner
427	552	11/4/2003	WM
427	553	11/4/2003	WM
427	555	11/4/2003	WM
427	558	11/4/2003	WM
427	226	11/4/2003	WM
427	248.1	11/4/2003	WM
427	255.18	11/4/2003	WM
427	255.23	11/4/2003	WM
427	256	11/4/2003	WM
427	258	11/4/2003	WM
427	259	11/4/2003	WM
427	261	11/4/2003	WM
427	264	11/4/2003	WM
427	265	11/4/2003	WM

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Inventor and Assignee search	11/4/2003	WM
Consulted Tim Meeks, primary, AU 1762, about art of using SAMs as CVD masking layers	11/4/2003	WM
EAST search, all databases	11/4/2003	WM
Consulted T. Meeks about subject matter of Claim 17 - active + inactive regions of CVD source	4/22/04	WM
Inv. + Assignee Search	4/22/04	WM
EAST Search, all DBs	4/22/04	WM



**THE UNIVERSITY OF CHICAGO**

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